



HEWLETT-PACKARD COMPANY
Intellectual Property Administration
P.O. Box 272400
Fort Collins, Colorado 80527-2400

Docket No.: 10002929-3
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Jeffrey C. Swanson et al.

Application No.: 10/670,620

Confirmation No.: 6729

Filed: September 25, 2003

Art Unit: 2113

For: A SYSTEM AND METHOD FOR MULTIPLE
CYCLE CAPTURE OF CHIP STATE

Examiner: M. C. Maskulinski

RESPONSE ACCOMPANYING
REQUEST FOR CONTINUED EXAMINATION

MS RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

This Response and RCE follows withdrawal of an appeal by Applicant in favor of further prosecution. Please reconsider the rejections for the above-identified U.S. patent application in view of the remarks contained herein.

A Listing of the Claims are reflected in a list which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.